



**ELECTRONIC COPY**

LG768643236  
Report verification at igi.org



January 30, 2026  
IGI Report Number **LG768643236**  
Description **LABORATORY GROWN DIAMOND**  
Shape and Cutting Style **CUT CORNERED  
RECTANGULAR MODIFIED  
BRILLIANT**  
Measurements **8.80 X 6.36 X 4.33 MM**  
**GRADING RESULTS**  
Carat Weight **2.04 CARATS**  
Color Grade **E**  
Clarity Grade **VS 1**

**LABORATORY GROWN DIAMOND REPORT**

January 30, 2026  
IGI Report Number **LG768643236**  
Description **LABORATORY GROWN DIAMOND**  
Shape and Cutting Style **CUT CORNERED RECTANGULAR  
MODIFIED BRILLIANT**  
Measurements **8.80 X 6.36 X 4.33 MM**

**GRADING RESULTS**

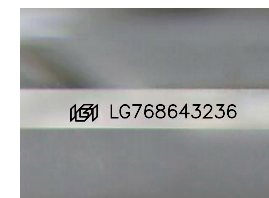
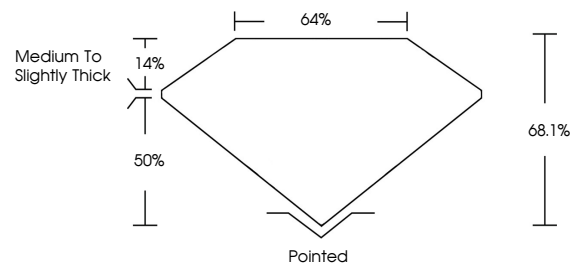
Carat Weight **2.04 CARATS**  
Color Grade **E**  
Clarity Grade **VS 1**

**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG768643236**

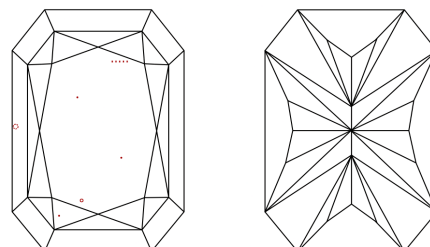
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

**PROPORTIONS**



Sample Image Used

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

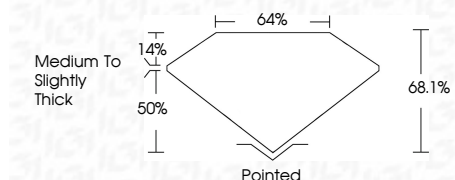
Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

FL	IF	VS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG768643236**  
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa



**IGI**



January 30, 2026  
IGI Report No LG768643236  
CUT CORNERED RECT. MODIFIED BRILLIANT  
8.80 X 6.36 X 4.33 MM  
2.04 CARATS  
E  
VS 1  
68.1%  
50%  
14%  
Medium to Slightly Thick  
Pointed  
EXCELLENT  
EXCELLENT  
NONE  
IGI LG768643236

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa